



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Enter
C.C.
12/6/06

In re Application of:

Ko et al.

Serial No.: 09/585,682

Filed: June 1, 2000

**For: SEMICONDUCTOR DEVICE
HAVING A SUBSTRATE, AN UNDOPED
SILICON OXIDE STRUCTURE, AND AN
OVERLYING DOPED SILICON OXIDE
STRUCTURE WITH A SIDEWALL
TERMINATING AT THE UNDOPED
SILICON OXIDE STRUCTURE (Amended)**

Confirmation No.: 7481

Examiner: C. Chu

Group Art Unit: 2815

**Attorney Docket No.: 2269-3526.2US
(97-1136.02/US)**

Notice of Allowance Mailed:

September 29, 2006

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EV 826303005 US

Date of Deposit with USPS: November 21, 2006

Person making Deposit: Brett Hooke

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows: